

Adam Pranda

List of Publications by Year in descending order

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7
papers

59
citations

1937685
4
h-index

1720034
7
g-index

7
all docs

7
docs citations

7
times ranked

66
citing authors

#	ARTICLE	IF	CITATIONS
1	Effect of nonvertical ion bombardment due to edge effects on polymer surface morphology evolution and etching uniformity. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , 2021, 39, .	2.1	1
2	Significance of plasma-photoresist interactions for atomic layer etching processes with extreme ultraviolet photoresist. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , 2020, 38, .	2.1	4
3	Substrate temperature effect on migration behavior of fluorocarbon film precursors in high-aspect ratio structures. <i>Journal of Vacuum Science and Technology B: Nanotechnology and Microelectronics</i> , 2019, 37, 031802.	1.2	3
4	Validation of etching model of polypropylene layers exposed to argon plasmas. <i>Plasma Processes and Polymers</i> , 2019, 16, 1900019.	3.0	11
5	Evolution of photoresist layer structure and surface morphology under fluorocarbon-based plasma exposure. <i>Plasma Processes and Polymers</i> , 2019, 16, 1900026.	3.0	6
6	Role of the dense amorphous carbon layer in photoresist etching. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , 2018, 36, 021304.	2.1	10
7	Polymer etching by atmospheric-pressure plasma jet and surface microdischarge sources: Activation energy analysis and etching directionality. <i>Plasma Processes and Polymers</i> , 2018, 15, 1700217.	3.0	24